



Image 1764/4

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

January 23, 2004

Applicants: Bruce M. Warnes et al.
For : CHEMICAL VAPOR DEPOSITION APPARATUS AND METHOD
Serial No.: 09/950 012 Group: 1764
Filed : Sept. 10, 2001 Examiner: Leung
Confirmation No. 9232

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PETITION FOR TIME EXTENSION

Sir:

A Response To Office Action is enclosed.
Pursuant to 37 CFR 1.136 (a), please extend the shortened period
for response by one (1) month. The extension fee is:

[X] \$ 110.00 (37 CFR 1.17a1)

[] \$ 55.00 (37 CFR 1.17a1; this application is entitled to
small entity status)

A check for \$110.00 is enclosed for the time extension fee. The
Commissioner is authorized to charge any additional extension or
other fee that may be necessary to deposit account No. 20-1124.

Respectfully submitted,

IN DUPLICATE

Edward J. Timmer (Reg.No. 27 402)

Encl: listed above

CERTIFICATE OF MAILING

I hereby certify that this correspondence and enclosures are being
deposited with the United States Postal Service as first class mail
in an envelope addressed to: Commissioner for Patents, P.O. Box
1450, Alexandria, VA 22313-1450 on January 23, 2004.

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Edward J. Timmer